



Basic Details

Organisation Chain	Department of Science and Technology Indian Association for the Cultivation of Science		
Tender Reference Number	IACS/SMS/PK/2019-20/110 Date 18/02/2020		
Tender ID	2020_MST_520202_1		
Tender Type	Open Tender	Form of contract	Buy
Tender Category	Goods	No. of Covers	2
Payment Mode	Offline	Is Multi Currency Allowed For BOQ	No
Is Multi Currency Allowed For Fee	No		

Payment Instruments

Offline	S.No	Instrument Type
	1	Bankers Cheque
	2	Bank Guarantee
	3	Demand Draft
	4	As Per Tender Document

Cover Details, No. Of Covers - 2

Cover No	Cover	Document Type	Description
1	Fee/PreQual/Technical	.pdf	Technical specification
2	Finance	.pdf	Price bid

Tender Fee Details, [Total Fee in ₹ * - 0.00]

Tender Fee in ₹	0.00		
Fee Payable To	NA	Fee Payable At	NA
Tender Fee Exemption Allowed	NA		

EMD Fee Details

EMD Amount in ₹	20,000	EMD Exemption Allowed	Yes
EMD Fee Type	fixed	EMD Percentage	NA
EMD Payable To	Indian Association for the Cultivation of Science	EMD Payable At	Kolkata

Work /Item(s)

Title	Plasma Etching System				
Work Description	Plasma Etching System				
Pre Qualification Details	Please refer Tender documents.				
Tender Value in ₹	10,00,000	Product Category	Laboratory and scientific equipment	Sub category	NA
Contract Type	Tender	Bid Validity(Days)	90	Period Of Work(Days)	30
Location	INDIAN ASSOCIATION FOR THE CULTIVATION OF SCIENCE	Pincode	700032	Pre Bid Meeting Place	Room No 202, Centenary Building IACS
Pre Bid Meeting Address	Indian Association for the Cultivation of Science (IACS), 2A and 2B Raja S C Mullick Road, Jadavpur, Kolkata 700032	Pre Bid Meeting Date	28-Feb-2020 02:30 PM	Bid Opening Place	Room No 202, Centenary Building IACS

Critical Dates

Publish Date	18-Feb-2020 05:00 PM	Bid Opening Date	06-Mar-2020 02:30 PM
Document Download / Sale Start Date	19-Feb-2020 11:00 AM	Document Download / Sale End Date	05-Mar-2020 12:30 PM
Clarification Start Date	NA	Clarification End Date	NA
Bid Submission Start Date	29-Feb-2020 11:00 AM	Bid Submission End Date	05-Mar-2020 12:30 PM

Tender Documents

NIT Document	S.No	Document Name	Description	Document Size (in KB)	
	1	Tendernotice_1.pdf	Plasma Etching System	38.24	
Work Item Documents	S.No	Document Type	Document Name	Description	Document Size (in KB)
	1	Tender Documents	Tender-iacs-sms-pk-19-20-110.pdf	Technical specification for Plasma Etching System	38.24

Tender Inviting Authority

Name	Registrar
Address	Indian Association for the Cultivation of Science (IACS), 2A and 2B Raja S C Mullick Road, Jadavpur, Kolkata 700032

Tender Creator Details

Created By	Sarbani Saha
Designation	Registrar
Created Date	18-Feb-2020 04:42 PM